

ABSTRACT OF THE DISCLOSURE

To provide a material arranging method, a film-forming apparatus, an electro-optical device and a manufacturing method thereof, an electronic device, and an electronic apparatus, capable of rapidly detecting a ejection failure of a nozzle, accomplishing reduction of defectives, and always stabilizing a state in which material is ejected. A film-forming apparatus according to the present invention comprises a pressure control system 12 for controlling the pressure in a vacuum chamber (processing chamber) 11 to a low pressure, at least one nozzle 15 for arranging material on a base (member) 14, a base stage 13 for holding the base 14, a driving system (moving means) 17 for relatively moving a position of the nozzle 15 or the base stage 13, and a detecting system (inspecting means) 19 for inspecting the material arranged on the base 14.